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APPLICANTS

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~~SIX~~ ** CONTINUING DATA ***** *none*

** FOREIGN APPLICATIONS ***** ~~SIX~~
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35 USC 119 (a-d) conditions met <input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance				
Verified and Acknowledged <i>Harold Shaw</i> Examiner's Signature Initials				

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TITLE

Method of fabricating top gate type thin film transistor having low temperature polysilicon

FILING FEE RECEIVED 858	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:	<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue)
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